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UNITED STATES PATENT and TRADEMARK OFFICE

UNDER SECRETARY OF COMMERCE FOR INTELLECTUAL PROPERTY AND DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE WASHINGTON, D.C. 20231 WWW.USPTO.GOV

DEC - 2 2002

In re Application of:

Dan Custer

Serial No. 09/298,160

Filed: April 22, 1999

For: POLISHING SYSTEMS, METHODS:

OF PRODUCING SUBSTRATES, AND

METHODS OF PREPARING LIQUIDS

NOTICE OF WITHDRAWAL

FROM ISSUE UNDER

37 CFR 1.313 (b)

The above-identified application is withdrawn from issue after payment of the issue fee due to: reopening of prosecution. <u>See 37 CFR 1.31(b).</u>

The above-identified application is hereby withdrawn from issue.

The issue fee is refundable upon written request. If, however, the application is again found allowable, the issue fee can be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Issue Fee Due upon request. This request and any balance due must be received on or before the due date noted in the new Notice of Allowance in order to prevent abandonment of the application.

Telephone inquiries should be directed to Randy Gulakowski at (703) 308-4333.

The above-identified application is being forwarded to the examiner for prompt appropriate action, including applicant of the new status of this application.

Gacquelue M. Stone

Jacqueline M. Stone, Director Technology Center 1700 Chemical and Materials Engineering 09/298,160

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cc: Allowed Files-PK3-910